

**RESPONSE UNDER 37 C.F.R. 1.116  
EXPEDITED PROCEDURE  
EXAMINING GROUP 1756**

Attorney Docket No. 9409-3

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re: Freese et al. Confirmation No.: 8346  
Serial No.: 10/661,917 Examiner: Daborah Chacko Davis  
Filed: September 11, 2003 Group Art Unit: 1756  
For: METHODS FOR MASTERING MICROSTRUCTURES THROUGH A  
SUBSTRATE USING NEGATIVE PHOTORESIST

May 22, 2007

Mail Stop AF  
Commissioner for Patents  
Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AFTER FINAL ACTION  
PURSUANT TO 37 C.F.R. § 1.116**

Sir:

The present Amendment is being filed to address the issues raised in the final Official Action mailed May 3, 2007.

It is not believed that an extension of time and/or additional fee(s)-including fees for net addition of claims-are required, beyond those that may otherwise be provided for in documents accompanying this paper. In the event, however, that an extension of time is necessary to allow consideration of this paper, such an extension is hereby petitioned under 37 C.F.R. § 1.136(a). Any additional fees believed to be due in connection with this paper may be charged to our Deposit Account No. 50-0220.

**Amendments** to the claims begin on Page 2 of this paper.

**Remarks** begin on Page 6 of this paper.

*please enter  
MD 06/05/07*